

Docket No.: 063979-0028



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takashi NISHIKAWA, et al.

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/616,917

Filed: July 11, 2003

Customer No.: 20277
Confirmation No.: 2411

Group Art Unit: 2822

Examiner: Kiesha L. Rose

Title: A SEMICONDUCTOR DEVICE AND A FABRICATION METHOD THEREOF

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF Amendment
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated July 27, 2005, having a three-month shortened statutory period for response set to expire October 27, 2005, a petition for a two month extension of time up to and including December 27, 2005 being filed concurrently herewith, please amend the above identified application as follows.

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~~01-FC-1252 450.00-DA~~